



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of: )  
Shunpei YAMAZAKI et al. )  
Serial No. 09/466,828 )  
Filed: 12/20/1999 )  
For: INSULATING FILM AND METHOD )  
OF PRODUCING SEMICONDUCTOR )  
DEVICE )

Art Unit: 2818  
Examiner: R. Berry

*Supple*  
*7/IDS*  
*J. Markey*  
*2-7-a*

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on Dec 22 2000.

*[Signature]*

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

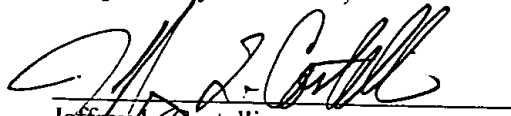
In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

In an Information Disclosure Statement submitted on December 13, 2000, English abstract translations were submitted for Japanese Patent Laid-Open Nos. 03-036767, 05-267480 and 01-238024. Full English translations are being submitted herewith.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

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Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Jeffrey L. Costellia', written over a horizontal line.

Jeffrey L. Costellia  
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